



- 1 -

... #FW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*In re* Patent Application of:

Docket No.: FIS920030183US1

Dureseti CHIDAMBARRAO, *et. al.*

Serial No.: 10/605,108

Group Art Unit: 2814

Filed: September 9, 2003

Examiner: PHAM, Long

For: **METHOD FOR REDUCED N+  
DIFFUSION IN STRAINED SI ON  
SI/GE SUBSTRATE**

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Sir:

In response to the **Non-Final Office Action** mailed **May 5, 2004** ("Office Action"), Applicants respectfully request reconsideration of the application in view of the following Amendments and Remarks.

Applicants believe that no further fees for net addition of claims are required at this time. Any fees required for further extensions of time and any fees for the net addition of claims are hereby authorized to be charged to **IBM Deposit Account No. 09-0458** (Fishkill).